

Appl. No.

10/695,379

: Confirmation No.:

5297

Applicant

Manchao Xiao et al.

Filed

October 27, 2003

For

PRECURSORS FOR DEPOSITING SILICON CONTAINING FILMS

AND PROCESSES THEREOF

Art Unit

1762

Examiner

B. Chen

Docket No.

06377ZP

Customer No.

23543

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Sir:

The following is responsive to the Office Action dated November 16, 2005 ("the Action"):

A one (1) month extension of time is requested and authorization to charge the \square . Account of assignee is provided in an enclosed form.

Amendments to the Specification begin on page П

of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on X page 2 of this paper.

П Amendments to the Drawings begin on page of this paper and include an

attached replacement sheet(s).

Amendments to the Abstract are on page the Abstract is on page of this paper. of this paper. A clean version of

X) Remarks/Arguments begin on page 7 of this paper.